

G8 1741

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Timothy A. Gessert	) Art Unit: 1741
Serial No.:	08/937,721	) Examiner: S. Mulburi
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Entitled:	Ion-Beam Treatment to Prepare Surfaces of P-CdTe Films	) Atty. Dkt. No. 96-48

## **CERTIFICATE OF MAILING UNDER 37 CFR § 1.8**

I hereby certify that the following attached items:

(1) Amendment Under 37 CFR § 1.115 (10 pages)

(2) Copy of Genuine Merriam-Webster definition of aperture (2 pages)

(2) postcard receipt

are being deposited in the United States Postal Service as first class mail, postage pre-paid, in an envelope addressed to: Assistant Commissioner for Patents, Box Non-Fee Amendment, Washington, DC. 20231 on this 16th day of December 1998.

Brenda E. Brantley
Patent Administrator

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